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TRANSMITTAL LETTER (General - Patent Pending)		RECEIVED		Docket No. IIZ.008D	
In Re Application Of: Jun KANAMORI <div style="float: right; text-align: right;">MAY 11 2001 TC 2800 MAIL ROOM</div>					
Serial No. 09/398,189	Filing Date September 17, 1999	Examiner S. Rao	Group Art Unit 2814		
Title: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE WITH SELF-ALIGNED SILICIDE AREAS FORMED USING A SUPPLEMENTAL SILICON OVERLAYER					
<u>TO THE ASSISTANT COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is: REQUEST FOR RECONSIDERATION					
in the above identified application.					
<div style="display: flex; justify-content: space-between;"><div><input checked="" type="checkbox"/> No additional fee is required. <input type="checkbox"/> A check in the amount of _____ is attached. <input checked="" type="checkbox"/> The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 50-0238 as described below. A duplicate copy of this sheet is enclosed.<div style="margin-left: 20px;"><input type="checkbox"/> Charge the amount of _____ <input checked="" type="checkbox"/> Credit any overpayment. <input checked="" type="checkbox"/> Charge any additional fee required.</div></div></div>					
<div style="text-align: center;"> _____ <i>Signature</i></div> <p>ANDREW J. TELESZ, JR. REG. NO. 33,581</p> <p>JONES VOLENTINE, P.L.L.C. 12200 SUNRISE VALLEY DRIVE, SUITE 150 RESTON, VA 20191</p> <p>TEL. NO.: (703) 715-0870</p>			<div style="border: 1px solid black; padding: 5px;"><p>I certify that this document and fee is being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.</p><div style="border-top: 1px solid black; height: 40px; margin-top: 10px;"></div><div style="border-top: 1px solid black; height: 40px; margin-top: 10px;"></div></div>		
CC:					